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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Inventor: Daniel I. Some
Title: Full Frame Thermal Pump Probe Technique For Detecting
Subsurface Defects
Serial No.: 10/812,817 Filing Date: March 29, 2004
Examiner: Unknown Group Art Unit: Unknown
Docket No.: APM003 US Confirmation No.:

Santa Clara, California
February 25, 2005

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR STATUS OF APPLICATION

Sir:

Applicant(s) hereby request(s) a report on the status of the above-identified patent application.

In particular, please advise when this application is expected to be examined.

If a telephone call would expedite this request, please telephone the undersigned attorney at (408) 982-8203.

I hereby certify that this correspondence is being transmitted by facsimile to the U.S. Patent and Trademark Office to the fax number 703-872-9306 on February 25, 2005.

S. Omkar

Attorney for Applicant(s)

Respectfully submitted,

S. Omkar

Omkar K. Suryadevara
Attorney for Applicant(s)
Reg. 36,320

SILICON VALLEY
PATENT GROUP LLP
3340 Mission College Blvd.
Suite 240
Santa Clara, CA 95054
(408) 982-8200
FAX (408) 982-8210

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